



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	)	Examiner: Michael Lebentritt
AKIRA UNNO ET AL.	)	Group Art: 2824
Application No.: 10/694,053	)	Allowed: August 18, 2004
Filed: October 28, 2003	; )	Confirmation No.: 3899
For: SEMICONDUCTOR SUBSTRATE, SOI SUBSTRATE AND MANUFACTURING METHOD THEREFOR	; ; )	November 18, 2004

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Sir:

The Notice of Allowability mailed August 18, 2004 included, as an attachment, a statement of reasons for allowance.

However, while the statement cites features of Claim 5, the statement erroneously attributes the cited features to Claim 4, which was cancelled in the Preliminary Amendment filed on October 28, 2003. Nevertheless, Applicants respectfully submit that each of the pending claims is allowable for its combination of claimed features.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

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